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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
YOSHIHIKO FUKUMOTO ET AL.  
Application No.: 09/429,530  
Filed: October 28, 1999  
For: METHOD FOR FABRICATING  
SEMICONDUCTOR DEVICE

)  
Examiner: V. Perez Ramos  
Group Art Unit:1765

)  
October 29, 2001

Assistant Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is enclosed.

The listed document was cited in a European Search Report in a European patent application corresponding to the above-identified application. A copy of this search report is included.

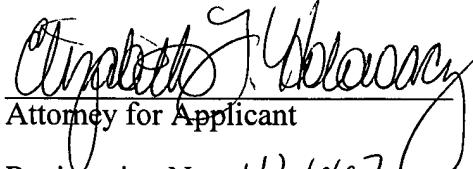
CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

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04/10/2002 VAUGURN 000001 0205 180.00  
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Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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